Day : Tuesday
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Time: 14:34:41

PALM INTRANET

Inventor Name Search Result

Your Search was:

Last Name = HARADA
First Name = KAZUHIRO

Application#	Patent#	Status	Date Filed	Title	Inventor Name
06436856	4508251	150	10/26/1982	CABLE PULLING/FEEDING APPARATUS	HARADA, KAZUHIRO
08985825	5877934	150	12/05/1997	CERAMIC COMPOSITION AND MULTILAYER CERAMIC CAPACITOR MADE THEREFROM	HARADA, KAZUHIRO
09028403	6008981	150	02/24/1998	MONOLITHIC CERAMIC CAPACITOR	HARADA, KAZUHIRO
09287710	6356037	150	04/07/1999	DIELECTRIC CERAMIC AND A CAPACITOR USING THE SAME	HARADA, KAZUHIRO
09467998	6380118	150	12/20/1999	NONLINEAR DIELECTRIC CERAMIC, PULSE GENERATING CAPACITOR, HIGH-PRESSURE VAPOR DISCHARGE LAMP CIRCUIT, AND HIGH-PRESSURE VAPOR DISCHARGE LAMP	HARADA, KAZUHIRO
09644183	6379460	150	08/23/2000	THERMAL SHIELD DEVICE AND CRYSTAL-PULLING APPARATUS USING THE SAME	HARADA, KAZUHIRO
09718659	Not Issued	161	11/22/2000	Silicon wafer and method for manufacturing the same	HARADA, KAZUHIRO
09987691	6650522	150	11/15/2001	SEMICONDUCTOR RELAY SYSTEM AND METHOD FOR CONTROLLING THE SEMICONDUCTOR RELAY SYSTEM	HARADA, KAZUHIRO
10239784	6671192	150	03/31/2003	POWER APPARATUS	HARADA, KAZUHIRO
10527566	Not Issued	30	01/06/2006	Heat shielding member of silicon single crystal pulling system	HARADA, KAZUHIRO

Applicants' Inventors

10561820	Not Issued	20	02/01/2007	Silicon single crystal pulling method	HARADA, KAZUHIRO
10769367	7208042	150	01/30/2004	METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL AND SILICON SINGLE CRYSTAL MANUFACTURED BY THE METHOD	HARADA, KAZUHIRO
10784411	7074271	150	02/23/2004	METHOD OF IDENTIFYING DEFECT DISTRIBUTION IN SILICON SINGLE CRYSTAL INGOT	HARADA, KAZUHIRO
11247168	Not Issued	25	10/12/2005	Electric blower	HARADA, KAZUHIRO
11382121	Not Issued	25	05/08/2006	Method For Manufacturing Nitrogen-Doped Silicon Single Crystal	HARADA, KAZUHIRO
11494490	Not Issued	30	07/28/2006	SYSTEM AND METHOD FOR PERSONAL IDENTIFICATIOIN USING BIOMETRICS DATA, AND COMPUTER-READABLE RECORDING MEDIUM IN WHICH PERSONAL IDENTIFICATION PROGRAM IS STORED	HARADA, KAZUHIRO
11574016	Not Issued	19	01/01/0001	ELECTRIC MOTOR DRIVING DEVICE, AND AIR CONDITIONER USING THE SAME	HARADA, KAZUHIRO
11605459	Not Issued	30	11/29/2006	Method and device for authenticating a person, and computer product	HARADA, KAZUHIRO

Inventor Search Completed: No Records to Display.

Search Another: Inventor **Last Name** Harada **First Name** Kazuhiro Search

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PALM INTRANET

Inventor Name Search Result

Your Search was:

Last Name = SUZUKI
First Name = YOJI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
06427039	4500639	150	09/29/1982	CULTURING BOULETELLA IN MEDIA CONTAINING ETHERIFIED CYCLODEXTRIN	SUZUKI, YOJI
06591169	Not Issued	161	03/19/1984	METHOD FOR THE PRODUCTION OF HA FRACTION CONTAINING PROTECTIVE ANTIGENS OF BORDETELLA PERTUSSIS AND PERTUSSIS VACCINE	SUZUKI, YOJI
06800634	Not Issued	166	11/05/1985	CEPHALOSPORIN DERIVATIVE, PROCESS FOR PRODUCTION THEREOF AND PHARMACEUTIAL USE THEREOF	SUZUKI, YOJI
06817946	4668782	250	12/17/1985	AN ANHYDROUS CRYSTALLINE OR CRYSTALLINE HEMIHYDRATE MONOHYDRATE OR TRIHYDRATE OF CEPHALOSPORIN DERIVATIVE	SUZUKI, YOJI
06874670	4687738	150	06/16/1986	METHOD FOR THE PRODUCTION OF HA FRACTION CONTAINING PROTECTIVE ANTIGENS OF BORDETELLA PERTUSSIS AND PERTUSSIS VACCINE	SUZUKI, YOJI
07205598	Not Issued	164	11/05/1987	3-(1-AZABICYCLO)-METHYL-CEPHALOSPORIN COMPOUNDS	SUZUKI, YOJI
07295724	5116942	150	12/02/1988	PROTEIN HAVING AN INFLAMMATORY	SUZUKI, YOJI

				PHOSPHOLIPASE A2 INHIBITORY ACTIVITY	
07362855	5153308	150	06/07/1989	S-SULFONATED CALCITONIN DERIVATIVES	SUZUKI, YOJI
07391595	Not Issued	161	07/31/1989	CEPHALOSPORIN COMPOUNDS OR THEIR SALTS, PROCESS FOR PRODUCTION OF SAME AND THEIR PHARMACEUTICAL COMPOSITIONS	SUZUKI, YOJI
07391616	Not Issued	161	07/31/1989	CEPHALOSPORIN COMPOUNDS OR THEIR SALTS, PROCESS FOR PRODUCTION OF SAME AND THEIR PHARMACEUTICAL COMPOSITIONS	SUZUKI, YOJI
07415203	Not Issued	161	08/24/1989	NOVEL TYPE OF HUMAN PHOSPHOLIPASE A2 AND ITS FRAGMENT PEPTIDE	SUZUKI, YOJI
07671803	Not Issued	166	05/31/1991	PROTEIN INHIBITORS OF PHOSPHOLIPASE A2 PURIFIED FROM INFLAMMATORY SITES, PRODUCTION PROCESS AND GENE THEREFOR	SUZUKI, YOJI
07775932	Not Issued	166	10/25/1991	METHOD OF SELECTING AND RECOVERING GENE RECOMBINANT ANIMAL CELLS	SUZUKI, YOJI
07852169	Not Issued	166	04/03/1992	PLASMID AND MICROBIAL CELL FOR PRODUCTION OF AN INHIBITORY PROTEIN FOR PHOSPHOLIPASE A2 FROM INFLAMMATORY SITES, AND THE PRODUCTION AND USE OF SAID PROTEIN	SUZUKI, YOJI
08047379	5344764	150	04/16/1993	PROTEIN INHIBITORS OF PHOSPHOLIPASE A2 PURIFIED FROM INFLAMMATORY SITES AND PRODUCTION PROCESS	SUZUKI, YOJI
08078486	Not Issued	161	06/17/1993	METHOD OF SELECTING AND RECOVERING GENE RECOMBINANT ANIMALS CELLS	SUZUKI, YOJI
08110205	Not Issued	161	08/23/1993	PLASMID AND MICROBIAL CELL FOR PRODUCTION OF AN INHIBITORY PROTEIN FOR PHOSPHOLIPASE A2 FROM	SUZUKI, YOJI

				INFLAMMATORY SITES, AND USE OF SAID PROTEIN	
08251249	5544191	150	05/31/1994	METAL VAPOR LASER CAPABLE OF COLD OPERATION	SUZUKI, YOJI
08355481	5919713	150	12/14/1994	SEMICONDUCTOR DEVICE AND METHOD OF MAKING	SUZUKI, YOJI
09270843	6455945	150	03/18/1999	SEMICONDUCTOR DEVICE HAVING A FRAGMENT OF A CONNECTION PART PROVIDED ON AT LEAST ONE LATERAL EDGE FOR MECHANICALLY CONNECTING TO ADJACENT SEMICONDUCTOR CHIPS	SUZUKI, YOJI
09578271	6463195	150	05/25/2000	METHOD OF MANUFACTURING POLARIZATION-MAINTAINING OPTICAL FIBER COUPLER	SUZUKI, YOJI
*09644183	6379460 Related Application	150	08/23/2000	THERMAL SHIELD DEVICE AND CRYSTAL-PULLING APPARATUS USING THE SAME	SUZUKI, YOJI
09694163	6428619	150	10/23/2000	SILICON WAFER, AND HEAT TREATMENT METHOD OF THE SAME AND THE HEAT-TREATED SILICON WAFER	SUZUKI, YOJI
09945622	6472738	150	09/05/2001	COMPOUND SEMICONDUCTOR DEVICE	SUZUKI, YOJI
09985488	6627714	150	11/05/2001	METHOD FOR PRODUCING AN OLEFIN TYPE COPOLYMER HAVING A CYCLIC STRUCTURE	SUZUKI, YOJI
10162012	6682597	150	06/03/2002	SILICON WAFER, AND HEAT TREATMENT METHOD OF THE SAME AND THE HEAT-TREATED SILICON WAFER	SUZUKI, YOJI
10301816	6930334	150	11/22/2002	HIGH FREQUENCY SEMICONDUCTOR DEVICE	SUZUKI, YOJI
*10527566	Not Issued Applicants' Application	30	01/06/2006	Heat shielding member of silicon single crystal pulling system	SUZUKI, YOJI
10561820	Not Issued	20	02/01/2007	Silicon single crystal pulling method	SUZUKI, YOJI
10769367	7208042	150	01/30/2004	METHOD OF MANUFACTURING SILICON	SUZUKI, YOJI

				SINGLE CRYSTAL AND SILICON SINGLE CRYSTAL MANUFACTURED BY THE METHOD	

Inventor Search Completed: No Records to Display.

Search Another: Inventor **Last Name** Suzuki **First Name** Yoji Search

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Inventor Name Search Result

Your Search was:

Last Name = FU
First Name = SENLIN

Application#	Patent#	Status	Date Filed	Title	Inventor Name
*09644183	6379460 Related Application	150	08/23/2000	THERMAL SHIELD DEVICE AND CRYSTAL-PULLING APPARATUS USING THE SAME	FU, SENLIN
*10527566	Not Issued Applicants' Application	30	01/06/2006	Heat shielding member of silicon single crystal pulling system	FU, SENLIN
10561820	Not Issued	20	02/01/2007	Silicon single crystal pulling method	FU, SENLIN
11357826	Not Issued	25	02/17/2006	Method for pulling up single crystal	FU, SENLIN

Inventor Search Completed: No Records to Display.

Search Another: Inventor **Last Name** Fu **First Name** Senlin Search

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Inventor Name Search Result

Your Search was:

Last Name = FURUYA
First Name = HISASHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
07313799	4981549	150	02/22/1989	METHOD AND APPARATUS FOR GROWING SILICON CRYSTALS	FURUYA, HISASHI
07933879	5264189	150	08/21/1992	APPARATUS FOR GROWING SILICON CRYSTALS	FURUYA, HISASHI
08420350	5474022	150	04/11/1995	DOUBLE CRUCIBLE FOR GROWING A SILICON SINGLE CRYSTAL	FURUYA, HISASHI
08502053	5674756	150	07/14/1995	METHOD FOR INTRINSIC-GETTERING SILICON WAFER	FURUYA, HISASHI
08626280	5714267	150	04/04/1996	SEED CRYSTAL OF SILICON SINGLE CRYSTAL	FURUYA, HISASHI
08633474	Not Issued	161	04/16/1996	TRANSISTOR STRUCTURE	FURUYA, HISASHI
08774183	5873938	150	12/26/1996	SINGLE CRYSTAL PULLING APPARATUS	FURUYA, HISASHI
08774184	5858087	150	12/26/1996	SINGLE CRYSTAL PULLING APPARATUS	FURUYA, HISASHI
08781818	5840115	150	01/10/1997	SINGLE CRYSTAL GROWTH METHOD	FURUYA, HISASHI
08781841	5871581	150	01/10/1997	SINGLE CRYSTAL PULLING APPARATUS	FURUYA, HISASHI
08781842	5891245	150	01/10/1997	SINGLE CRYSTAL PULLING METHOD AND APPARATUS FOR ITS IMPLEMENTATION	FURUYA, HISASHI
08781843	5779792	150	01/10/1997	SINGLE CRYSTAL PULLING APPARATUS	FURUYA, HISASHI
08791777	5895527	150	01/29/1997	SINGLE CRYSTAL PULLING APPARATUS	FURUYA, HISASHI
08822489	5797638	150	03/24/1997	HOIST APPARATUS FOR ANNULAR MEMBER	FURUYA, HISASHI
08825637	5843228	150	04/01/1997	APPARATUS FOR	FURUYA, HISASHI

				PREVENTING HEATER ELECTRODE MELTDOWN IN SINGLE CRYSTAL PULLING APPARATUS	
08834293	5897706	150	04/15/1997	METHOD FOR CRUCIBLE ATTACHMENT TO SUPPORT BASE OF SINGLE CRYSTAL PULLING APPARATUS AND SUPPORT BASE ASSEMBLY APPARATUS AND SUPPORT BASE EMPLOYED THEREIN	FURUYA, HISASHI
09644183	6379460 Related Application	150	08/23/2000	THERMAL SHIELD DEVICE AND CRYSTAL-PULLING APPARATUS USING THE SAME	FURUYA, HISASHI
09667885	6663708	150	09/22/2000	SILICON WAFER, AND MANUFACTURING METHOD AND HEAT TREATMENT METHOD OF THE SAME	FURUYA, HISASHI
09694163	6428619	150	10/23/2000	SILICON WAFER, AND HEAT TREATMENT METHOD OF THE SAME AND THE HEAT-TREATED SILICON WAFER	FURUYA, HISASHI
09718659	Not Issued	161	11/22/2000	Silicon wafer and method for manufacturing the same	FURUYA, HISASHI
10162012	6682597	150	06/03/2002	SILICON WAFER, AND HEAT TREATMENT METHOD OF THE SAME AND THE HEAT-TREATED SILICON WAFER	FURUYA, HISASHI
10527566	Not Issued	30	01/06/2006	Heat shielding member of silicon single crystal pulling system	FURUYA, HISASHI
10628690	Not Issued	161	07/28/2003	Method of manufacturing silicon	FURUYA, HISASHI

Applicants' Inventions

Inventor Search Completed: No Records to Display.

Search Another: Inventor

Last Name Furuya

First Name Hisashi

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Inventor Name Search Result

Your Search was:

Last Name = ABE
First Name = HIDENOBU

Application#	Patent#	Status	Date Filed	Title	Inventor Name
*10527566	Not Issued	30 Applicants' Invention	01/06/2006	Heat shielding member of silicon single crystal pulling system	ABE, HIDENOBU
10769367	7208042	150	01/30/2004	METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL AND SILICON SINGLE CRYSTAL MANUFACTURED BY THE METHOD	ABE, HIDENOBU

Inventor Search Completed: No Records to Display.

Search Another: Inventor Last Name: Abe First Name: Hidenobu Search

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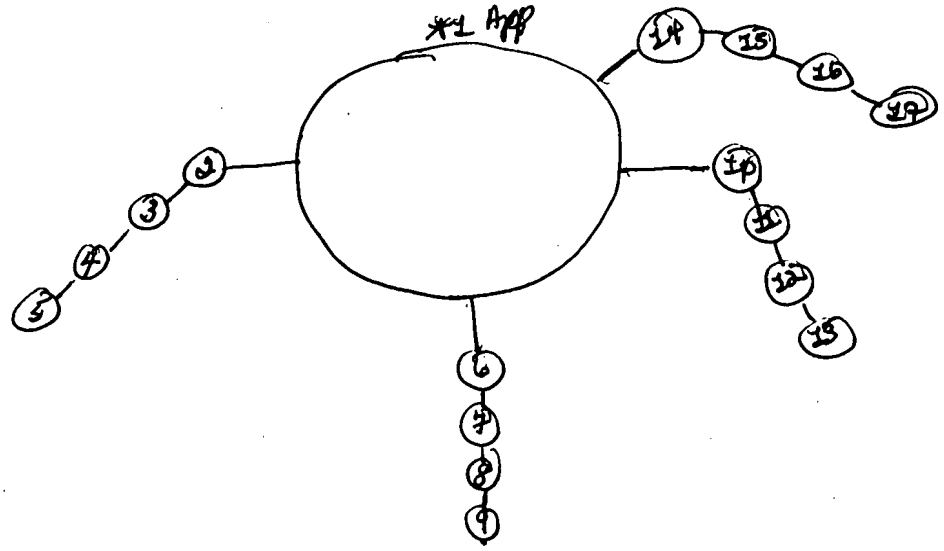
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Examiner's Notes

M903 (3/7/2006)

S(heat? (Ba) shield or heat? (Ba) baffle#)
S (COSF or oxidation (w) induced (w) Stacking (w) Fault#)
S(COP or crystal (w) originated (w) particle)
S(TDDB or Time (w) Dependent (w) Dielectric (w) Breakdown)
S(TZDB or Time (w) zero (w) Dielectric (w) Breakdown)

*Priority Document Rec'd JP-2002-271240 09/18/2003



103 Rej

Claims 1-17 are rejected using "U.S. Pat. No. 6,379,460 B1 (Harada et al). Harada, et al does not exactly teach a heat accumulating portion ~~has~~ is a thermal conductivity of 5W/(m°C) or less..." or "the minimum distance (W2) betwn the outer peripheral face ... and the inner peripheral face of the heat accumulating portion is 10mm or more and 0.2d or less.